



**ELECTRONIC COPY**

**LABORATORY GROWN DIAMOND REPORT**

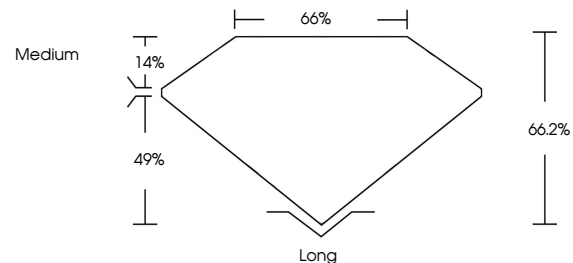
February 2, 2026  
IGI Report Number **LG772605755**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **9.83 X 6.68 X 4.42 MM**  
**GRADING RESULTS**  
Carat Weight **2.86 CARATS**  
Color Grade **E**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG772605755**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

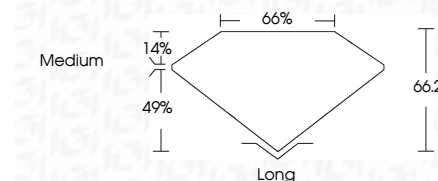
| FL       | IF                  | VVS <sup>1-2</sup>          | VS <sup>1-2</sup>      | SI <sup>1-2</sup> | I <sup>1-3</sup> |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included         |



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**IGI**



February 2, 2026  
IGI Report No **LG772605755**  
**EMERALD CUT**  
9.83 X 6.68 X 4.42 MM  
2.86 CARATS  
Color Grade **E**  
Clarity Grade **VVS 2**  
Depth **66.2%**  
Table **66%**  
Girdle **Medium**  
Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG772605755**  
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